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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:

Docket No.: 6192.0329.US

Jae-Jin LYU

Confirmation No.: 4849

Application No.: 10/725,595

Group Art Unit: 2871

Filed: December 3, 2003

Examiner: CHEN, Wen Ying Patty

For: LIQUID CRYSTAL DISPLAY APPARATUS AND METHOD OF
MANUFACTURING SUBSTRATE OF THE SAME

MAIL STOP - AMENDMENT

Commissioner for Patents

P.O. BOX 1450

Alexandria, VA 22313-1450

RESPONSE TO ELECTION/RESTRICTION REQUIREMENT

Sir:

In reply to the June 27, 2005, Restriction Requirement, Applicant elects Group I, and Species I, drawn to a device forming a retardation layer on the upper substrate of the liquid crystal display apparatus, without traverse.

It is not believed that any extensions of time or fees are required. If extensions of time are necessary to prevent abandonment of this application, then such extensions of time are hereby petitioned for under 37 C.F.R. §1.136(a) and are hereby authorized to be charged to our Deposit Account No. 23-1951.

Respectfully Submitted,

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Date: July 20, 2005

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